AF 12622



RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITED PROCEDURE GROUP 2622** PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No. Q53219

Takeshi KAMIMURA

Appln. No. 09/244,419

Group Art Unit: 2622

Confirmation No. 3733 Examiner: Joseph R. POKRZYWA

Filed: February 4, 1999

For: **IMAGE WORKFLOW SYSTEM** 

RESPONSE UNDER 37 C.F.R. § 1.116

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MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

NOV 2 5 2003

Technology Center 2600

Sir:

The following remarks, which begin on the next separate page, are submitted in response to the Office Action dated August 27, 2003.